Application/Control No. 09/532,915 Applicant(s)/Patent Under Reexamination HAYAKAWA ET AL. Examiner A. Sefer Applicant(s)/Patent Under Reexamination HAYAKAWA ET AL. Page 1 of 1

Notice of References Cited

U.S. PATENT DOCUMENTS

r	Ι	Degument Number	/ Data	U.S. FAILNI DOCUMENTS	1
*		Document Number Country Code-Number-Kind Code	/ Date MM-YYYY	Name	Classification
	Α	US-5,73,325	06-1998	Teramoto	438/151
	В	US-5,508,532	04-1996	Teramoto	257/59
0	С	US-6,093,577	07-2000	Van der Groen	438/30
	D	US-6,087,229	07-2000	Aronowitz et al	438/287
	Ε	US-5,108,843	04-1992	Ohtaka et al	428/446
	F	US-5,273,920	12-1993	Kwasnick et al	438/40
	G	US-			\ 1
	Н	US-			
	ı	US-			
	J	US-			-
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν	JP 9-162405	06-1997	Japan	Yamazaki et al	
	0	WO 99/10918	03-1999	PCT	lyer et al	
	Р	JP 11-223839	08-1999	Japan	Misawa et al	
	Q	JP 10-135469	05-1998	Japan	Yamazaki et al	
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	٧							
	w							
	x							

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.